

PATENT

10/715,955

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Re Application of:

Jeff Mackey

Serial No.: 10/715,955

Filed: November 15, 2003

For: POLARIZED RETICLE,
PHOTOLITHOGRAPHY SYSTEM, AND
METHOD OF FORMING A PATTERN
USING A POLARIZED RETICLE IN
CONJUNCTION WITH POLARIZED
LIGHT

Confirmation No.: Unknown

Examiner: Unknown

Group Art Unit: Unknown

Attorney Docket No.: 2269-6102US

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 1, 2004
Date

Signature

Deidra J. Pfeil
Name (Type/Print)

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Prior to examination of the above-referenced patent application on the merits, entry of the amendments as set forth herein is respectfully solicited.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing which begins on page 9 of this paper.

Amendments to the Drawings appear on page 19 of this paper and include both an annotated sheet showing changes and replacement formal drawings.

Serial No. 10/415,955

Remarks begin on page 20 of this paper.

An Appendix including amended drawing figure is attached following page 20 of this paper.